JC20 Rec'd PCT/PTO 2 3 SEP 2005

XA-10437 PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of:

NISHIZAWA, Hirotaka et al.

Intl. Appln. No.: PCT/JP2004/013930

Intl. Filing Date: 24 September 2004

For: SEMICONDUCTOR DEVICE

INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Attn: Mail Stop PCT, DO/EO/US

Sir:

Pursuant to 37 C.F.R. § 1.56, and without any assertion as to materiality or prior art effect, the documents listed on the attached Form PTO-1449 are hereby cited.

The document on the attached List was cited in the specification, on pages 1-2, and its relevance is indicated therein.

Respectfully submitted,

MWS:sjk

Miles & Stockbridge P.C. 1751 Pinnacle Drive, Suite 500 McLean, Virginia 22102-3833 (703) 903-9000

September 23, 2005

3y:

Mitchell W. Shapiro

Reg. No. 31,568

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FORM PTO-1449					Atty. Docket No. Appln. No.				
INFORMATION DISCLOSURE STATEMENT LIST OF DOCUMENTS CITED BY APPLICANT					XA-10437	0/550559			
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